Application/Control No. O9/821,134 Applicant(s)/Patent Under Reexamination HIMMEL ET AL. Examiner Un C Cho Applicant(s)/Patent Under Reexamination HIMMEL ET AL. Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2001/0018340 A1	08-2001	Tagi, Minoru	455/414
	В	US-6,647,269 B2	11-2003	Hendrey et al.	455/3.03
	С	US-2003/0050837 A1	03-2003	Kim, Do Sik	705/14
	D	US-			
	Е	US-			
	F	US-			
	G	US-			
	Н	US-			
	_	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification	
	N						
	0						
	Р						
	Q						
	R						
	s						
	Т						

NON-PATENT DOCUMENTS

NON-I ATENT BOOMENTO							
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	υ						
	٧						
	8						
	X						

A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.